

PATENT  
Atty. Dkt. No. AMAT/6493/ETCH/SILICON/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OFFICIAL

In re Application of:  
Nallan, et al.

Serial No.: 09/993,240

Confirmation No.: 6869

Filed: November 13, 2001

For: Apparatus for Controlling a  
Thermal Conductivity Profile for  
a Pedestal in a Semiconductor  
Wafer Processing Chamber

Group Art Unit: 2835 1763

Examiner: R.N. Kackar

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Commissioner for Patents  
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37 CFR 1.8

I hereby certify that this correspondence is being deposited on  
July 2, 2003 with the United States Postal Service as First  
Class Mail in an envelope addressed to: Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-1450

July 2, 2003  
Date

Signature

Dear Sir:

RESPONSE TO OFFICE ACTION DATED APRIL 3, 2003

In response to the Office Action dated April 3, 2003, having a shortened statutory period for response set to expire on July 3, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6493/AOP, \$240.00 for excess claim fees, and any additional amount for other fees, including extension of time fees, required to make this response timely and acceptable to the Office.